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Substitute for form 1449A/PTO			<b>Complete if Known</b>		
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (use as many sheets as necessary)			Application Number	TBD 10/792,084	
			Filing Date	Herewith	
			First Named Inventor	Chang, et al.	
			Art Unit	TBD	
			Examiner Name	TBD	
Sheet	1	of	1	Attorney Docket Number	TSM02-0858

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U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No.	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code <sup>2</sup> (if known)			
[Signature]	A	US-3,877,834	07-18-1972	Mathisen	
	B	US-3,712,813	01-23-1973	Ross, et al.	
	C	US-4,734,345	03-29-1988	Nomura, et al.	
	D	US-4,857,425	08-15-1989	Phillips	
	E	US-4,868,428	10-30-1990	Phillips	
	F	US-6,187,372	02-18-1993	Chube	
	G	US-5,504,598	04-02-1998	Goto, et al.	
	H	US-5,528,380	08-18-1998	Goto, et al.	
	I	US-5,774,240	08-30-1998	Goto, et al.	
		US-			
	US-				
	US-				
	US-				

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No.	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>3</sup>
		Country Code <sup>3</sup> - Number <sup>4</sup> - Kind Code <sup>5</sup> (if known)				
[Signature]	J	DT-1 331 076 GB	09-19-1973	SIEMENS		

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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
[Signature]	K	WOLF, STANLEY, Ph.D. and TAUBER, RICHARD N., Ph.D.; Silicon Processing for the VLSI Era, 2000; pp. 615-635; Volume 1: Process Technology Second Edition; Lattice Press, Sunset Beach, California.	
[Signature]	L	MÜTZEL, MARIO; "Building 3D Nanostructures with Holograms"; STP-Gateway; April 3, 2002; <a href="http://www.stp-gateway.de/Archiv/archiv475-e.html">http://www.stp-gateway.de/Archiv/archiv475-e.html</a>	
[Signature]	M	MARDER, SETH, et al.; "Materials Absorb Two Photons, Generate Acid on Cue"; UniSci Daily University Science News; May 13, 2002; <a href="http://unisci.com/stories/20022/0513023.htm">http://unisci.com/stories/20022/0513023.htm</a>	
[Signature]	N	STILES, LORI; "Cornell Researchers Collaborate on a Major Advance in Microfabrication"; Cornell Chronicle; May 16, 2002; <a href="http://www.news.cornell.edu/Chronicle/02/5.16.02/Ober-3D_fab.html">http://www.news.cornell.edu/Chronicle/02/5.16.02/Ober-3D_fab.html</a>	

Examiner Signature	[Signature]	Date Considered	12/06
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. \*Applicant's unique citation designation number (optional). \*See Kinds Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. \*Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). \*For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. \*Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. \*Applicant is to place a check mark here if English language translation is attached.

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